June, 2015: Ph. D. degree in Mechanical Engineering, Guangdong University of Technology, Guangzhou, China

June, 2009: B. S. degree in Industrial Engineering, Guangdong University of Technology, Guangzhou, China

Intelligent Control Technology

Introduction to Algorithm Theory

Operations Research

Semiconductor manufacturing systems, scheduling and control, discrete event systems, Petri nets

July 2022   Present:Associate Professor at the Institute of Systems Engineering, Macau University of Science and Technology, Macao

Jan. 2018   June 2022: Assistant Professor at the Institute of Systems Engineering, Macau University of Science and Technology, Macao

Jan. 2016   Dec. 2017: Postdoctoral Fellow at the Institute of Systems Engineering, Macau University of Science and Technology, Macao

Sep. 2014   Sep. 2015: Visiting student at the department of Electrical and Computer Engineering, New Jersey Institute of Technology, USA

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Professional Certification and Awards

Senior Member of IEEE

Best Paper Award in Application, for the paper virtual wafer-based scheduling method for dual-arm cluster tools with chamber cleaning by Y. Qiao, J. Li, Y. J. Lu, S. W. Zhang, N. Q. Wu, and B. Liu, IEEE International Conference on Networking, Sensing and Control, Xiamen, China, December 3-5, 2021;

The 2018 Science and Technology Award of Jiangxi Province of China-The Second Prize of Natural Science Award;

2018 BOC (Bank of China) Excellent Research Award

The 2018 Science and Technology Award of Macau-The Third Prize of Natural Science Award

Journal Editorship

Special Issue Guest Editor of IEEE Robotics and Automation Magazine, Machine Learning for Industry 4.0, 20

Personal Website

https://www.scholat.com/yqiao